

# John Provine

## List of Publications by Year in descending order

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Version: 2024-02-01

40  
papers

765  
citations

567281

15  
h-index

642732

23  
g-index

43  
all docs

43  
docs citations

43  
times ranked

1246  
citing authors

#	ARTICLE	IF	CITATIONS
1	Approaching the Limits of Aspect Ratio in Free-standing Al <sub>2</sub> O <sub>3</sub> 3D Shell Structures. <i>Advanced Engineering Materials</i> , 2022, 24, .	3.5	2
2	Extending the limits of Pt/C catalysts with passivation-gas-incorporated atomic layer deposition. <i>Nature Catalysis</i> , 2018, 1, 624-630.	34.4	63
3	Back-end-of-line compatible Poly-SiGe lateral nanoelectromechanical relays with multi-level interconnect. <i>Microsystem Technologies</i> , 2017, 23, 2125-2130.	2.0	3
4	Process Control of Atomic Layer Deposition Molybdenum Oxide Nucleation and Sulfidation to Large-Area MoS <sub>2</sub> Monolayers. <i>Chemistry of Materials</i> , 2017, 29, 2024-2032.	6.7	47
5	Plasma-enhanced atomic layer deposition of superconducting niobium nitride. <i>Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films</i> , 2017, 35, .	2.1	20
6	Correlation of film density and wet etch rate in hydrofluoric acid of plasma enhanced atomic layer deposited silicon nitride. <i>AIP Advances</i> , 2016, 6, .	1.3	39
7	Plasma-enhanced atomic layer deposition of tungsten nitride. <i>Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films</i> , 2016, 34, 051516.	2.1	4
8	Plasma-Enhanced Atomic Layer Deposition of SiN <sub>x</sub> -AlN Composites for Ultra Low Wet Etch Rates in Hydrofluoric Acid. <i>ACS Applied Materials &amp; Interfaces</i> , 2016, 8, 17599-17605.	8.0	15
9	Parallel preparation of plan-view transmission electron microscopy specimens by vapor-phase etching with integrated etch stops. <i>Ultramicroscopy</i> , 2016, 166, 39-47.	1.9	5
10	High-density waveguide superlattices with low crosstalk. <i>Nature Communications</i> , 2015, 6, 7027.	12.8	116
11	Integrated atomistic chemical imaging and reactive force field molecular dynamic simulations on silicon oxidation. <i>Applied Physics Letters</i> , 2015, 106, 011602.	3.3	21
12	Depletion of cells and abundant proteins from biological samples by enhanced dielectrophoresis. <i>Sensors and Actuators B: Chemical</i> , 2014, 193, 918-924.	7.8	27
13	Double-Layer Silicon Photonic Crystal Fiber-Tip Temperature Sensors. <i>IEEE Photonics Technology Letters</i> , 2014, 26, 900-903.	2.5	16
14	Combinational Logic Design Using Six-Terminal NEM Relays. <i>IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems</i> , 2013, 32, 653-666.	2.7	32
15	Laterally actuated nanoelectromechanical relays with compliant, low resistance contact. , 2013, , .		4
16	Dual-beam, six-terminal nanoelectromechanical relays. , 2013, , .		0
17	A photonic crystal cavity-optical fiber tip nanoparticle sensor for biomedical applications. <i>Applied Physics Letters</i> , 2012, 100, .	3.3	29
18	Double-layer silicon photonic crystal fiber tip temperature sensor. , 2012, , .		2

#	ARTICLE	IF	CITATIONS
19	Electrical properties of CuPc-based OTFTs with atomic layer deposited HfAlO gate dielectric. , 2012, , .		0
20	Nano-Electro-Mechanical relays for FPGA routing: Experimental demonstration and a design technique. , 2012, , .		28
21	Application of principal component analysis to a full profile correlative analysis of FTIR spectra. Surface and Interface Analysis, 2012, 44, 365-371.	1.8	11
22	Integration of nanoelectromechanical (NEM) relays with silicon CMOS with functional CMOS-NEM circuit. , 2011, , .		49
23	Optical fiber tips functionalized with semiconductor photonic crystal cavities. Applied Physics Letters, 2011, 99, .	3.3	43
24	Photonic Crystal Fiber Tip Sensor for High-Temperature Measurement. IEEE Sensors Journal, 2011, 11, 2643-2648.	4.7	26
25	Multilayered Monolithic Silicon Photonic Crystals. IEEE Photonics Technology Letters, 2011, 23, 730-732.	2.5	7
26	Dual sidewall lateral nanoelectromechanical relays with beam isolation. , 2011, , .		9
27	A Method for Wafer-Scale Encapsulation of Large Lateral Deflection MEMS Devices. Journal of Microelectromechanical Systems, 2010, 19, 28-37.	2.5	75
28	pH sensor demonstrating a layout programmable squeeze pumped microfluidic platform. , 2010, , .		0
29	Characterization of Encapsulated Micromechanical Resonators Sealed and Coated With Polycrystalline SiC. Journal of Microelectromechanical Systems, 2010, 19, 357-366.	2.5	19
30	High temperature photonic crystal fiber tip sensor. , 2010, , .		2
31	Electromechanical sensing of charge retention on floating electrodes. , 2010, , .		0
32	Monolithic silicon photonic crystal slab fiber tip sensor. , 2009, , .		5
33	Photonic crystal fiber tip sensor for precision temperature sensing. , 2009, , .		5
34	Laser-printed magnetic-polymer microstructures. , 2009, , .		2
35	Large-Area Subwavelength Aperture Arrays Fabricated Using Nanoimprint Lithography. IEEE Nanotechnology Magazine, 2008, 7, 527-531.	2.0	27
36	The dependence of poly-crystalline SiC mid-infrared optical properties on deposition conditions. , 2008, , .		0

#	ARTICLE	IF	CITATIONS
37	Phonon Polariton Reflectance Spectra In a Silicon Carbide Membrane Hole Array. Conference Proceedings - Lasers and Electro-Optics Society Annual Meeting-LEOS, 2007, , .	0.0	0
38	Extraordinary Transmission Through A Poly-SiC Membrane with Subwavelength Hole Arrays. , 2007, , .		3
39	Effect of a Vertical Stack of Aligned Subwavelength Metal Hole Arrays on Extraordinary Transmission Spectra. , 2007, , .		0
40	Tunable Subwavelength Metal Gratings in the Mid-IR Band. IEEE Journal of Selected Topics in Quantum Electronics, 2007, 13, 270-276.	2.9	9